Application/Control No.	Applicant(s)/Patent under Reexamination
10/821,161	MEIER ET AL.
Examiner	Art Unit
John C. Douglas	1764

SEARCHED					
Class	Subclass	Date	Examiner		
208	208R	10/30/2006	JCD		
208	247	10/30/2006	JCD		
208	299	10/30/2006	JCD		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
		<u> </u>			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
See SEarch History from EAST	10/30/2006	JCD		
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